Notice of References Cited Application/Control No. | Applicant(s)/Patent Under Reexamination | PAVEY, NICHOLAS | Examiner | Art Unit | Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	В	US-			
	U	US-6,675,138	01-2004	Hollander et al.	703/13
	۵	US-6,694,497	02-2004	Pavey, Nicholas	716/4
	E	US-			
	F	US-			
	G	US-			
	Н	US-			
	ı	US-			
	J	US-			
	K	US-			
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Ø					
	R					
	S					
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Liu et al.; Efficient coverage analysis metric for HDL design validation; IEEE Proc. Comp. & Digital Techniques; pp. 1-6; 1/2001.
	v	Gharehbaghi et al.; Behavioral test generation for VHDL processes; IEEE Proc. 12th Int. Conf. Microelectronics; pp. 123-126; 10/2000.
	w	
	х	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.